

| L Number | Hits | Search Text | DB | Time stamp |
|----------|------|--|--|------------------|
| 1 | 3702 | ((257/296) or (257/401) or (257/410)).CCLS. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; | 2002/11/06 16:38 |
| 2 | 0 | (((257/296) or (257/401) or (257/410)).CCLS.) and "bird's beak" near4 gate near4 underneath and silicon adj nitride | US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; | 2002/11/06 16:39 |
| - | 5 | 272,968.ap. | US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; | 2002/11/06 16:38 |
| - | 1 | "5612249".PN. | USPAT | 2002/05/22 14:58 |
| - | 1 | "5637514".PN. | USPAT | 2002/05/22 14:59 |
| - | 1 | "5798550".PN. | USPAT | 2002/05/22 14:59 |
| - | 1 | "6015736".PN. | USPAT | 2002/05/22 15:00 |
| - | 3 | ("5306655").PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; | 2002/05/22 15:43 |
| - | 3 | ("5360758").PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; | 2002/05/22 17:03 |
| - | 301 | ((side adj wall or sidewall or side-wall) adj spacer near6 nitride) and 257/\$6.ccls. and (field adj effect adj transistor or fet or mos or mos adj fet or mosfet or nmos or pmos or nmosfet or pmosfet) ("5382533").PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; | 2002/05/23 09:41 |
| - | 3 | ("5679968").PN. | US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; | 2002/05/22 17:51 |
| - | 3 | ("5714413").PN. | US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; | 2002/05/22 17:52 |
| - | 0 | ("ep-621632\$-.did.").PN. | US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; | 2002/05/22 17:53 |
| - | 0 | ("ep-621632\$-.did.").PN. | US-PGPUB; EPO; JPO; DERWENT; IBM TDB USPAT; | 2002/05/22 17:53 |
| - | 0 | rajeevakumar.in. and dram adj cell adj structure | EPO | 2002/05/22 17:55 |
| - | 6 | rajeevakumar.in. and dram adj cell adj structure | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2002/05/22 17:55 |

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| - | 2 | ("5612249").PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2002/11/06 12:04 |
| - | 0 | (side adj wall or sidewall) near12 gate adj oxide near12 silicon adj nitride adj spacer | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2002/11/06 12:06 |
| - | 15 | (side adj wall or sidewall) near12 gate adj oxide near12 silicon adj nitride | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2002/11/06 12:07 |
| - | 147 | oxidation adj barrier near4 oxide | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2002/11/06 13:06 |
| - | 201 | (MOS or MOSFET).ti,ab,clm. and silicon adj nitride near4 (sidewall or side adj wall) near4 spacer | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2002/11/06 13:09 |